


<div>Search Notes</div> <div></div>	Application/Control No.	Applicant(s)/Patent under Reexamination	
	10/606,382	LEE, GAB JAE	
	Examiner	Art Unit	
	VAN T. PHAM	2627	

SEARCHED			
Class	Subclass	Date	Examiner
369	116, 53.26.	12/1/2005 updated on 5/7/6	VP VP

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
East (PGPUB; USPAT; USOCR;EPO;JPO;DERWENT;IBM_T DB) 369, 385 (text search only see search history printout).	5/7/2006	VP